WEST Search History

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DATE: Thursday, September 08, 2005

Hide?	<u>Set</u> <u>Name</u>	Query	<u>Hit</u> Count
DB=PGPB,USPT,USOC; PLUR=YES; OP=ADJ			
n	L14	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same ((nitrogen oxide) or 'NO.sub.2') same (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10') same (oxygen or 'O.sub.2')	4
	L13	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same ((nitrogen oxide) or 'NO.sub.2') same plasma same (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10') same (oxygen or 'O.sub.2')	1
	L12	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same ((nitrogen oxide) or 'NO.sub.2') same plasma same (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10') same (oxygen or 'O.sub.2')	1
n	L11	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same (((nitrogen oxide) or 'NO.sub.2')with plasma with (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10') with (oxygen or 'O.sub.2'))	0
	L10	L9 and 15	9
	L9	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same ((nitrogen oxide) or 'NO.sub.2')	336
	L8	L7 and 15	951
	L7	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same ('NO' or 'NO.sub.2')	49366
\Box	L6	L5 and 13	2
	L5	134/1.1,22.1,22.18,902;438/905.ccls.	3929
	$DB=EPAB,JPAB,DWPI,TDBD;\ PLUR=YES;\ OP=ADJ$		
<u>.</u>	L4	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same (('NO' or 'NO.sub.2') with plasma with (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10') with (oxygen or 'O.sub.2'))	0
	DB=B	PGPB,USPT,USOC; PLUR=YES; OP=ADJ	
	L3	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same (('NO' or 'NO.sub.2') with plasma with (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10') with (oxygen or 'O.sub.2'))	26
	DB=I	PGPB,USPT,USOC,EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ	
	L2	((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same (('NO' or 'NO.sub.2') with plasma with (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10') with (oxygen or 'O.sub.2'))	26
		((chamber or apparatus or reactor) with (clean\$3 or etch\$3)) same (('NO' or	

L1 'NO.sub.2') with plasma with (fluorocarbon or 'CF.sub.4' or 'C.sub.2F.sub.6' or 'C.sub.3F.sub.8' or 'C.sub.4F.sub.10'))

65

END OF SEARCH HISTORY